



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

HARAGUCHI et al

Serial No. 10/761,191

Filed: January 22, 2004

Atty. Ref.: 2018-836

TC/A.U.: 1753

Examiner:

For: GAS CONCENTRATION DETECTOR

\* \* \* \* \*

September 21, 2006

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

**INFORMATION DISCLOSURE STATEMENT**

Attention is directed to the attached Japanese Examination Report (with English translation) in a counterpart of this application and to a copy of each non-US patent document newly cited therein. A Form PTO-1449 is also attached.

Official consideration and citation of all identified documents is requested.

Respectfully submitted,

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**APPLICANT**

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## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

**OTHER DOCUMENTS** (including Author, Title, Date, Pertinent pages, etc.)

[illegible]

**\*Examiner**

Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.